

<b>Notice of References Cited</b>	Application/Control No. 10/811,375		Applicant(s)/Patent Under Reexamination KIM ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0135862	09-2002	Dewald, D. Scott	359/298
*	B	US-6,493,149	12-2002	Ouchi, Satoshi	359/634
*	C	US-6,839,095	01-2005	Bierhuizen et al.	349/9
*	D	US-2002/0180933	12-2002	Ito, Yoshitaka	353/20
*	E	US-2002/0191154	12-2002	Shahzad et al.	353/20
*	F	US-6,288,815	09-2001	Lambert, Nicolaas	359/196
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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